REMARKS

The specification has been amended to indicate the identity of Figures 1(A)-1(D) through 5(A)-5(D).

Attached hereto is a marked-up version of the changes made to the specification by the current Amendment. The attached pages are captioned "Version with markings to show changes made."

Early, favorable prosecution on the merits is respectfully requested.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,

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VERSION WITH MARKINGS TO SHOW CHANGES MADE

In the Specification:

Please amend the paragraphs beginning at page 7, lines 3-16 as follows:

[FIG.1] <u>FIGS. 1(A)-1(D)</u> [is a process diagram] <u>are process diagrams</u> for showing a method for manufacturing an NMOSFET device according to a first embodiment of the present invention;

[FIG.2] <u>FIGS. 2(E)-2(H)</u> [is a continued process diagram] <u>are continued process</u> <u>diagrams</u> for showing a method for manufacturing the NMOSFET device according to the first embodiment of the present invention;

[FIG.3] <u>FIGS. 3(I)-3(L)</u> [is a further continued process diagram] <u>are further continued</u> <u>process diagrams</u> for showing the method for manufacturing the NMOSFET device according to the first embodiment of the present invention;

[FIG.4] <u>FIGS. 4(A)-4(D)</u> [is a process diagram] <u>are process diagrams</u> for showing a method for manufacturing an NMOSFET device according to a second embodiment of the present invention;

[FIG.5] <u>FIGS. 5(A)-5(D)</u> [is a process diagram] <u>are process diagrams</u> for showing a method for manufacturing a prior art NMOSFET device; and